

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

MMB Docket No. **1003-0547**

LSI Reference: **99-230**

Confirmation No.: **4444**

Application of: **Michael J. Berman**

Group Art Unit: **2624**

Serial No.: **09/553,140**

Examiner: **Aaron W. Carter**

Filed: **April 20, 2000**

For: **Determination of Film Thickness During Chemical Mechanical Polishing**

I hereby certify that this correspondence is being transmitted via the Electronic Filing System (EFS) to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

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**AMENDMENT**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated March 27, 2009, please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper; and

**Remarks/Arguments** begin on page 9 of this paper.